

Search Notes

Application/Control No.

10/726,821

Examiner

Marissa J. Detschel

Applicant(s)/Patent under
Reexamination

FUKUI, KENJI

Art Unit

2877

SEARCHED

Class	Subclass	Date	Examiner
356	515	11/29/2005	MJD
356	521	11/29/2005	MJD
356	489	11/29/2005	MJD
356	495	11/29/2005	MJD
356	512	11/29/2005	MJD

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Consulted Sam Turner of 356 for search strategy	11/29/2005	MJD
Searched all point diffraction interferometers in EAST	11/29/2005	MJD
See EAST search history	11/30/2005	MJD
Google search for point diffraction interferometers	11/30/2005	MJD